

S/N: TBA

11/24/2003

Docket No.: SUG-176-USAP

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: TO BE ASSIGNED

Confirmation No.: TO BE ASSIGNED

Applicant: Kazunori HAGIMOTO et al.

Art Unit: TO BE ASSIGNED

Filed: November 24, 2003

Examiner: TO BE ASSIGNED

Docket No: SUG-176-USAP

Customer No: 28892

For: Light-Emitting Device, Method of Fabricating the Same, and
OHMIC Electrode Structure for Semiconductor Device

INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 C.F.R. §§ 1.56, 1.97, and 1.98

US Patent & Trademark Office
2011 South Clark Place
Customer Window
Crystal Plaza Two, Lobby, Room 1B03
Arlington, VA 22202

Sir:

In compliance with the dictates of 37 C.F.R. §§ 1.56, 1.97, and 1.98, Applicant hereby submits an Information Disclosure Statement.

The attached documents are mentioned in the present specification and a brief description of their relevance can be found therein.

It is respectfully requested that the Examiner consider each of these references and indicate such consideration by enclosing an appropriately initialled copy of the enclosed form PTO-1449 with the next communication from the Patent Office.

Respectfully submitted,

A handwritten signature in black ink, appearing to read 'R. Snider', with a long horizontal line extending to the right.

Ronald R. Snider
Attorney of Record
Reg. No. 24,962

Date: November 24, 2003

Snider & Associates
Ronald R. Snider
P.O. Box 27613
Washington, D.C. 20038-7613
(202) 347-2600

RRS/jt

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PTO FORM 1449 SUBMISSION

FOREIGN PATENT DOCUMENTS				
Examiner Initials*	Foreign Patent Document Number	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	T**
	JP-7066455 English Abstract	Shin Etsu Handotai Co.	March 10, 1995	
	JP-11191641 English Abstract	Matsushita Electron Corp.	July 13, 1999	
	JP-2001-339100 English Abstract	Shin Etsu Handotai Co.	December 7, 2001	

Examiner Signature		Date Considered	
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***Examiner:** Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

****Applicant** is to place a check mark here if English language translation is attached